



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

51048-2 DIV

In re application of:  
Goela et al.

Serial No.: 09/870,242

Filed: May 30, 2001

For: METHOD AND APPARATUS FOR  
PRODUCING FREE-STANDING SILICON  
CARBIDE ARTICLES

: Group Art Unit: 1772

: Examiner: Brian P. Egan

RECEIVED  
SEP 29 2003  
TC 1700

9/10  
N.E.  
10/15/03  
PC

REQUEST FOR CONTINUED EXAMINATION UNDER 37 CFR § 1.114

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Rejection dated June 24, 2003, Applicants respectfully request continued examination of the above-identified patent application.

Amendments to the claims are reflected in the listing of claims, which begin on page 2 of this paper.

Remarks begin on page 3.